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400 Garden City Plaza - Suite 300 Garden City, New York 11530 (516) 742-4343 - Telephone (516) 742-4368 - Facsimile e-mail: intprop@ssmp.com

# SCULLY, SCOTT, MURPHY & PRESSER

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To:	Examiner Fazli Erdem	From:	Leslie S. Szivos					
Fax:	: (571) 273-8300		11 pages including cover sheet					
Phone:		Date:	8/19/2005					
Re:	U.S. Serial No: 10/696,634 Group Art Unit: 2826 Confirmation No: 5489	CC:						
	Docket No: YOR920030394US1 (1696	63)						
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1.	Certificate of Transmission by Facsimile							
2.	Amendment Transmittal Letter (in duplicate)							
<b>3</b> .	Amendment and Response							

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CERTIFICATE OF Applicant(s): Meikei Iee	Docket No. YOR920030394US1 (16963)									
Application No. 10/696,634	Filing Date October 29, 2003	Examiner Fazli Erdem		Group Art Unit 2826						
Invention: CMOS ON HYBRID SUBSTRATE WITH DIFFERENT CRYSTAL ORIENTATIONS USING SILICON-TO										
SILICON DIRECT WAFER BONDING										
Confirmation No.: 5489										
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on August 19 (Date)										
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AMENDA Applicant(s): Mei	rge Entity)		Docket No. YOR920030394US1 (16963)							
Application No. 10/696,634	Filing Date October 29, 2003	Examiner Fazli Erdem		Customer N 23389	lo.	Group Art Unit 2826	Confirmation No. 5489			
Invention: CMOS ON HYBRID SUBSTRATE WITH DIFFERENT CRYSTAL ORIENTATIONS USING SILICON-TO SILICON DIRECT WAFER BONDING										
COMMISSIONER FOR PATENTS:  Transmitted herewith is an amendment in the above-identified application.										
The fee has been co	alculated and is trans	mitted as shown below.								
		CLAIMS AS AM	ENDED	)						
	CLAIMS REMAINING	HIGHEST #	NUMBI	ER EXTRA		RATE	ADDITIONAL			
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS	PRESENT		TV-T	FEE			
TOTAL CLAIMS	18 -	58 =		0	х	\$50.00	\$0.00			
INDEP. CLAIMS	2 -	4 =		0	x	\$200.00	\$0.00			
Multiple Dependent	Claims (check if appl	icable)					\$0.00			
		TOTAL ADDITIONAL F	EE FO	R THIS AME	NE	MENT	\$0.00			
No additional fee is required for amendment.  Please charge Deposit Account No. in the amount of  A check in the amount of to cover the filing fee is enclosed.  The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM  Any additional filing fees required under 37 C.F.R. 1.16.  Any patent application processing fees under 37 CFR 1.17.  Payment by credit card. Form PTO-2038.  WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.										
I - li - S S -i	Signature									
Leslie S. Szivos ' Registration No. 39, SCULLY, SCOTT, 400 Garden City Pla Garden City, New 1 (516) 742-4343	ER .	hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents. P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFB 1.8(a)] on (Date)  Signature of Person Mailing Correspondence								
					Typed or Printed Name of Person Mailing Correspondence					

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### AUG 19 2005

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Meikei Ieong et al.

Examiner: Fazli Erdem

**Dated:** August 19, 2005

Serial No: 10/696,634

Art Unit: 2826

Filed: October 29, 2003

Docket: YOR920030394US1 (16963)

For: CMOS ON HYBRID SUBSTRATE

WITH DIFFERENT CRYSTAL

ORIENTATIONS USING SILICON-TO SILICON DIRECT WAFER BONDING

Confirmation No.: 5489

Mail Stop Amendment Commissioner for Patents United States Patent Office Alexandria, VA 23313-1450

### AMENDMENT AND RESPONSE

Sir:

In response to the Office Action dated August 11, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

#### **CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: August 19, 2005

Leglie S. Szivos